# OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

## **Application Data Sheet**

### **Application Information**

Application Type::

Regular

Subject Matter::

Utility

CD-ROM or CD-R:

None

Title::

SUBSTRATE INSPECTION SYSTEM,

SUBSTRATE INSPECTION METHOD, AND SUBSTRATE INSPECTION APPARATUS

Attorney Docket Number::

119216

**Total Drawing Sheets::** 

7

Small Entity::

No

## **Applicant Information**

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

**Full Capacity** 

Given Name::

Kazuhiko

Family Name::

**FUKAZAWA** 

City of Residence::

Tokyo

Country of Residence::

Japan

Applicant Authority type::

Inventor

**Primary Citizenship Country::** 

Japan

Status::

**Full Capacity** 

Given Name::

Yasuto

Family Name::

**KAWASHIMA** 

City of Residence::

Tokyo

Country of Residence::

Japan

#### **Correspondence Information**

Correspondence Customer Number::

25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-084741	03/26/2003	Yes
Assignee Infor	mation		
Assignee Name::		NIKON CORPORATION	
Street of mailing address::		2-3, Marunouchi 3-Chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		100-8331	

Page 2 3/24/04